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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA

Application No.: 09/697,639

Docket No.: 105193.01

Filed: October 27, 2001

For: EXPOSURE APPARATUS AND METHOD OF FABRICATION
A MICRO-DEVICE USING THE EXPOSURE APPARATUS



REQUEST FOR CORRECTION OF PALM RECORDS

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

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Respectfully submitted,

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Registration No. 27,075

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Thomas J. Pardini
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Date: January 11, 2001

OLIFF & BERRIDGE, PLC
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Alexandria, Virginia 22320
Telephone: (703) 836-6400

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Bib Data Sheet

SERIAL NUMBER 09/697,639	FILING DATE 10/27/2000 RULE	CLASS 355	GROUP ART UNIT 2851	ATTORNEY DOCKET NO. 105193.01
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APPLICANTS

Hideki Komatsuda, Kawasaki-shi, JAPAN;

** CONTINUING DATA ****

THIS APPLICATION IS A CIP OF 09/259,137 02/26/1999 *27*

** FOREIGN APPLICATIONS ****

JAPAN 10-047400 02/27/1998 *27*

JAPAN 10-263673 09/17/1998

JAPAN 2000-051374 02/25/2000

*056137*IF REQUIRED, FOREIGN FILING LICENSE
GRANTED ** 01/05/2001

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 21	TOTAL CLAIMS 46	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>27</i>	Initials			

ADDRESS

Oliff & Berridge PLC
 P O Box 19928
 Alexandria , VA 22320

TITLE

Exposure apparatus and method of fabricating a micro-device using the exposure apparatus

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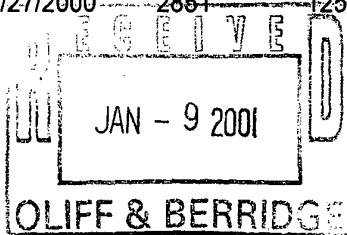
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/697,639	10/27/2000	2851	1258	105193.01	21	46	4

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FILING RECEIPT



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Applicant(s)

Hideki Komatsuda, Kawasaki-shi, JAPAN;

Continuing Data as Claimed by Applicant

THIS APPLICATION IS A CIP OF 09/259,137 02/26/1999

Foreign Applications

JAPAN 10-047400 02/27/1998
JAPAN 10-263673 09/17/1998
JAPAN 2000-500437 02/25/2000
2000-050137

If Required, Foreign Filing License Granted 01/05/2001

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Title

APPARATUS

Exposure apparatus and method of fabricating a micro-device using the exposure apparatus

Preliminary Class

355

Data entry by : NIMMONS, EVELYN

Team : OIPE

Date: 01/05/2001

